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ATTENTION: BOX AFTER FINAL  
RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE REQUESTED  
EXAMINING GROUP 1722

PATENT  
Customer No. 22,852  
Attorney Docket No. 04329.2230

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kenji HASHIMOTO

Application No.: 09/503,170

Filed: February 14, 2000

For: RESIN ENCAPSULATING  
APPARATUS AND METHOD  
USED IN A MANUFACTURE OF A  
SEMICONDUCTOR DEVICE

Group Art Unit: 1722

Examiner: R. Davis

Assistant Commissioner for Patents  
Washington, DC 20231

Sir:

**AMENDMENT AFTER FINAL**

In reply to the Final Office Action of January 24, 2003, and pursuant to 37 C.F.R.  
§ 1.116, Applicant proposes that this application be amended as follows:

**IN THE CLAIMS:**

Please amend claims 1 and 8, as follows:

1. (Twice Amended) A resin encapsulating apparatus comprising:  
a retaining section which retains a semiconductor device;

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